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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yasuhiro SHIMADA et al.

Application No.: 09/819,906

Filed: March 29, 2001

For: ELECTRON OPTICAL SYSTEM ARRAY,  
METHOD OF MANUFACTURING THE  
SAME, CHARGED-PARTICLE BEAM  
EXPOSURE APPARATUS, AND DEVICE  
MANUFACTURING METHOD

Examiner: Unassigned

Group Art Unit: 2881

March 5, 2003

Commissioner for Patents  
Washington, D.C. 20231

LETTER SUBMITTING CORRECTED PTO-1449 FORM

RECEIVED  
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TC 2800 MAIL ROOM

Sir:

In reviewing the above-identified application, Applicants have noticed an error in the Notice of Art Cited by Applicant (PTO-1449 form) attached to the Information Disclosure Statement filed on January 29, 2003. Specifically, U.S. Patent No. "6,381,702" listed on the PTO-1449 form should read -- 6,381,072 --. Accordingly, Applicants submit herewith a corrected PTO-1449 form.

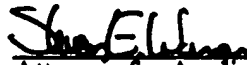
Applicants request that the information cited in the above-noted Information Disclosure Statement be considered and that a copy of the enclosed corrected PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee under 37 CFR 1.97(c)(2) is believed to be due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

**Match & Return**

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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SEW/cab